EXAMINER <u>&.c/r</u>		DATE CONSIDE		5D \$ 000 D		
		DATE CONSIST	nrn			
	OTHER DOCUMEN	ITS (Including Au	 uthor, Title, Date, Per	tinent Pages,	Etc.)	
C.C.	2000-059835	06/18/2002	Japan	H04B	1/38	Yes (Abstract)
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)
	F	OREIGN PATI	ENT DOCUMENTS	S		
•						
•	•					Ť
				T	Technology Center 260	
					SEP 1 5	
					RECF	VED
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE APPROPRIA
VIIII		U.S. PATEN	T DOCUMENTS			
(Use several sheets if necessary)			Filing Date 12/28/2001		Group Art Unit 2681	
INFO _E	MATION DISCLOSURE CI IN AN APPLICATION	TATION	Applicant In I	Hwan Hwan	g; Yu Chan B	yun
FORM PTO-1449			Docket Number (Optional) Application Number 2060-3-16 10/034,894			

INFORMATION DISCLOSURE CITATION IN AN APPLICATION JUL 1 9 2004 Use several sheets if necessary)			Docket Number (6 2060-3-		Application Number 10/034,894		
			Applicant In Hwan Hwang, Yu Chan Byun				
			Filing Date 12/28/20	001	Group Art Unit 2681		
CVANIE OF THE PARTY OF THE PART		U.S. PATEN	T DOCUMENTS				
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
					-		
•				RE	CEIVE	D	
				JI	L 2 1 2004		
				Techne	logy Center	2000	
			1				
	F	OREIGN PATE	ENT DOCUMENTS	<u> </u>	T		
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)	
. C.C.	10-269154	10/09-1998	Japan	G06F	13/00	Yes (Abstract)	
C.C.	11-017783	01/22/1999	Japan	H04M	1/00	Yes (Abstract)	
CC.	11-308360	11/05/1999	Japan	H04M	11/00	Yes (Abstract)	
C.C.	2000-184420	06/30/2000	Japan	H04Q	7/14	Yes (Abstract)	
<u></u>							
	OTHER DOCUMEN	ITS (Including Au	ıthor, Title, Date, Per	tinent Pages,	Etc.)		
							
EXAMINER	L	DATE CONSIDER					
C,CHOW.			9/20/04				
EXAMINER: In conformance a	nitial if citation considered, whether o and not considered. Include copy of	or not citation is in this form with next	conformance with MPI tommunication to the	EP § 609; Drav e applicant.	v line through cit	lation if not in	

PTO/SB/ 08 (10-92)